

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Group Art Unit: N/A

GRIMBERGEN, ET AL.

Examiner: Unknown

Serial No.: N/A

Attorney Docket No.

Filed: Herewith

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For:

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PROCESS RESIDUES ON A September 13, 2000

SURFACE IN A CHAMBER

San Francisco, California

## **INFORMATION DISCLOSURE STATEMENT**

Box PATENT APPLICATION Commissioner for Patents Washington, D.C. 20231

Dear Examiner:

Attached hereto are PTO-1449 forms listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of each form be returned to the undersigned.

According to 37 C.F.R. § 1.98(d), a copy of any patent, publication, or other information listed in an information disclosure statement is not required to be provided if it was previously cited by, or submitted to, the Office in a prior application, provided that the prior application is properly identified in the statement and relied upon for an earlier filing date under 35 U.S.C. § 120.

This application is a continuation-in-part that relies upon an earlier filing date from patent application serial no. 09/096,728, under 35 U.S.C. § 120. All of the references cited in the present application have already been cited in the parent application. Thus, Applicant believes that under 37 C.F.R. § 1.98(d), the copies of the cited references do not need to be provided herein because the Examiner can obtain the same from the parent file.

If, however, the Examiner would like separate copies of these references, the Examiner is respectfully requested to call the undersigned for the same.

Respectfully submitted,

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Date: 9-13-00

3y:

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Encl.